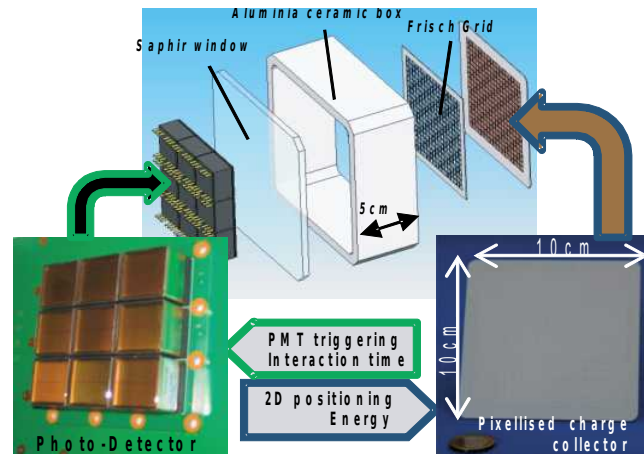
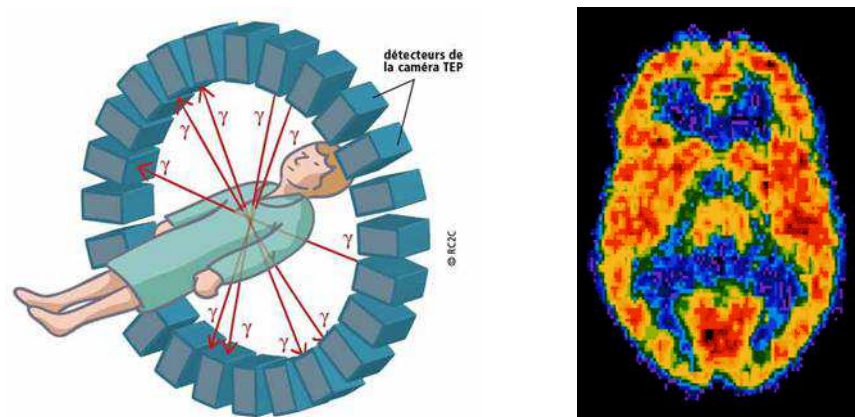
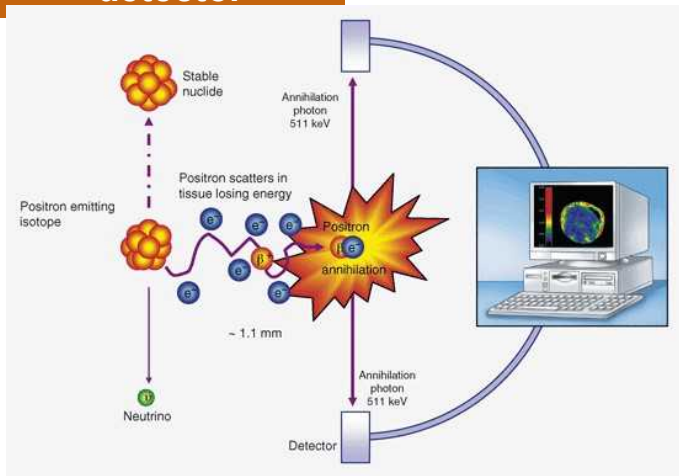
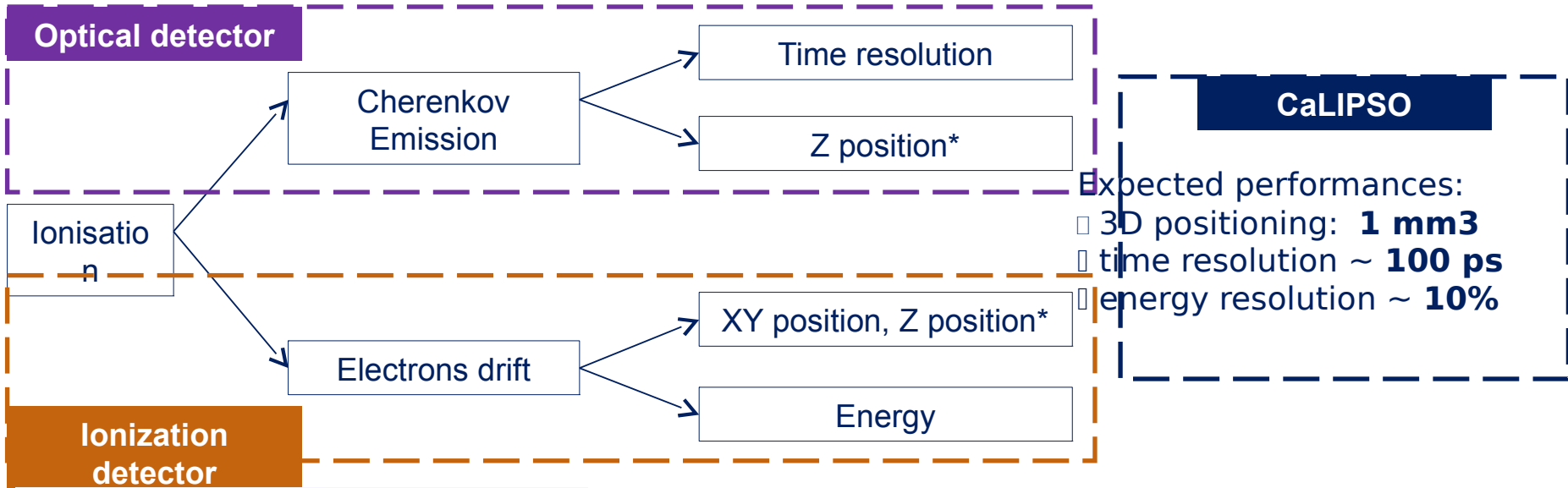


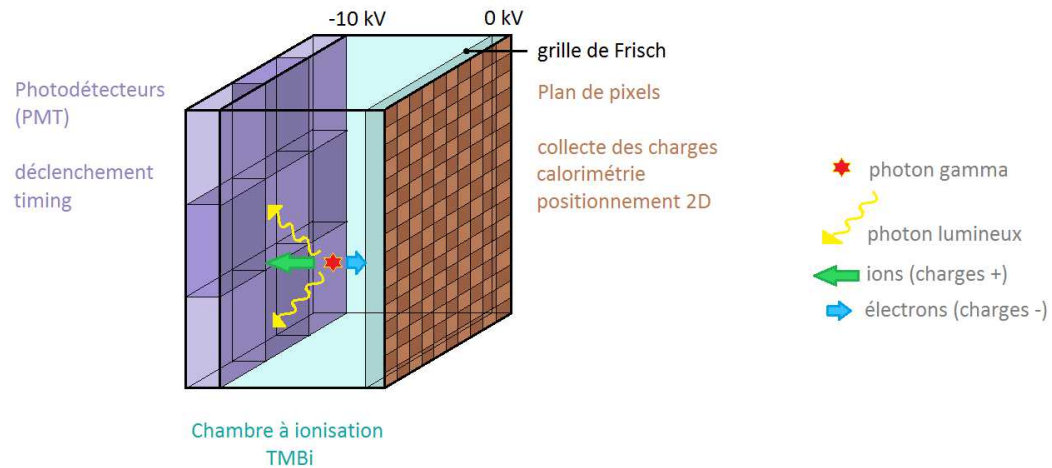
# Technologie détecteur de charge ultravide multipixellisé avec électronique ASIC bas bruit et ultrapurification

- I. Physical principle
- II. Ultrapurification
- III. Single pixel detector
- IV. Electronics
- V. Measurements
- VI. Conclusion



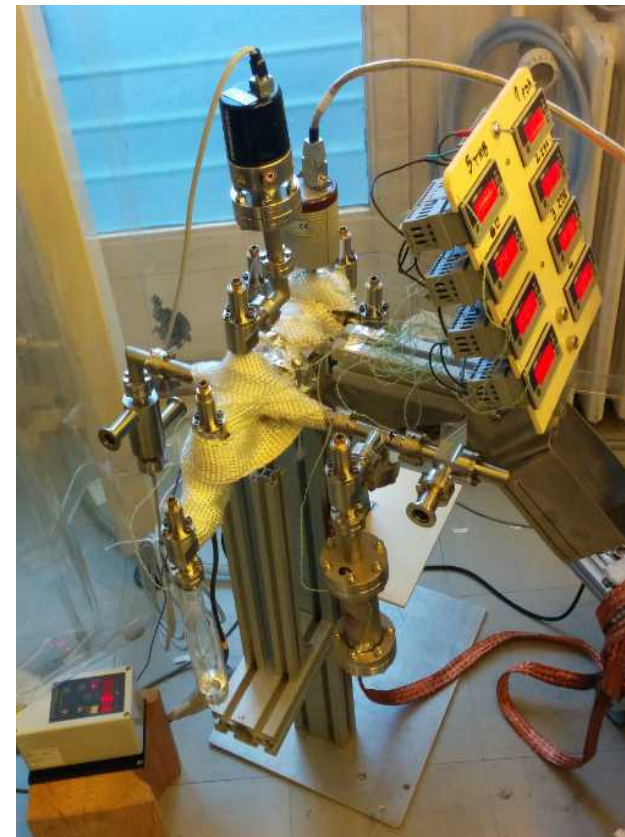


PET principle



CaLIPSO detector principle

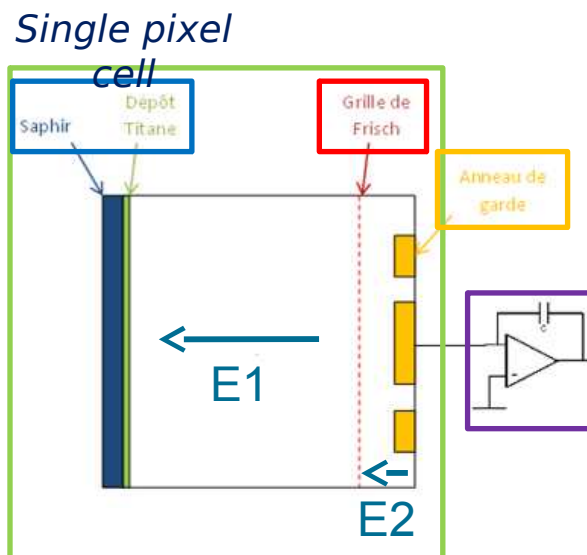
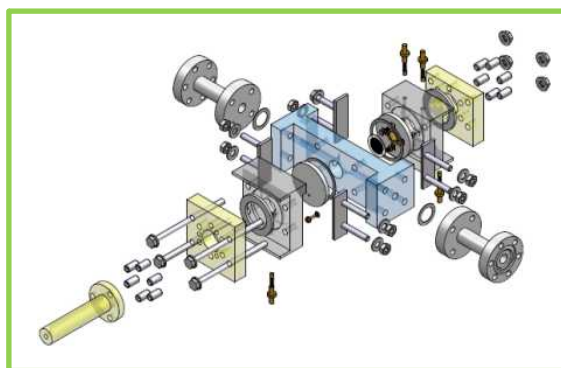
- Electronegative impurities reduce the signal by capturing electrons
  - ultrapurification  $< 0,1$  ppm oxygen equivalent (electrons lifetime  $> 10 \mu\text{s}$ )
  - **molecular sieve (3A, 4A, 5A and 13X zeolites)**
  - batch and column devices



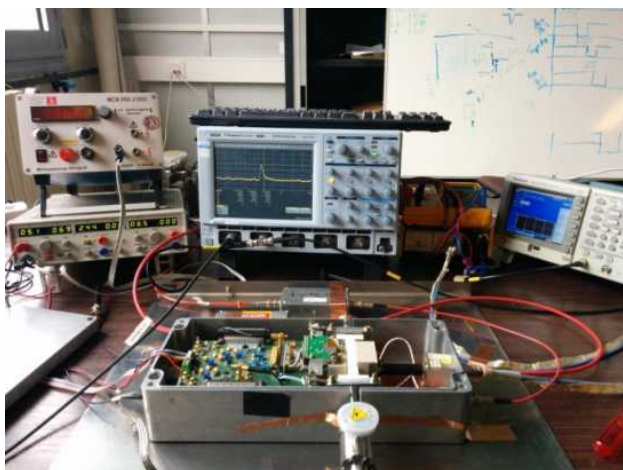
*Batch (r.) and column  
(u.) ultrapurification  
stations*

# Single Pixel Detector

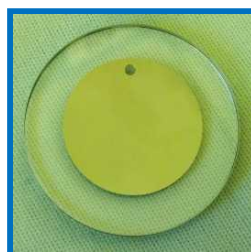
- Ionization chamber
- Very weak signals (pA, fC) □ Eliminate every noise sources



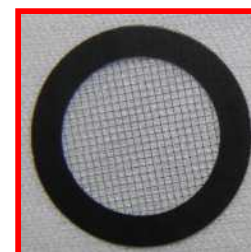
*Single pixel cell picture*



*Single pixel cell electronic readout*



*Titanium layer on sapphire*

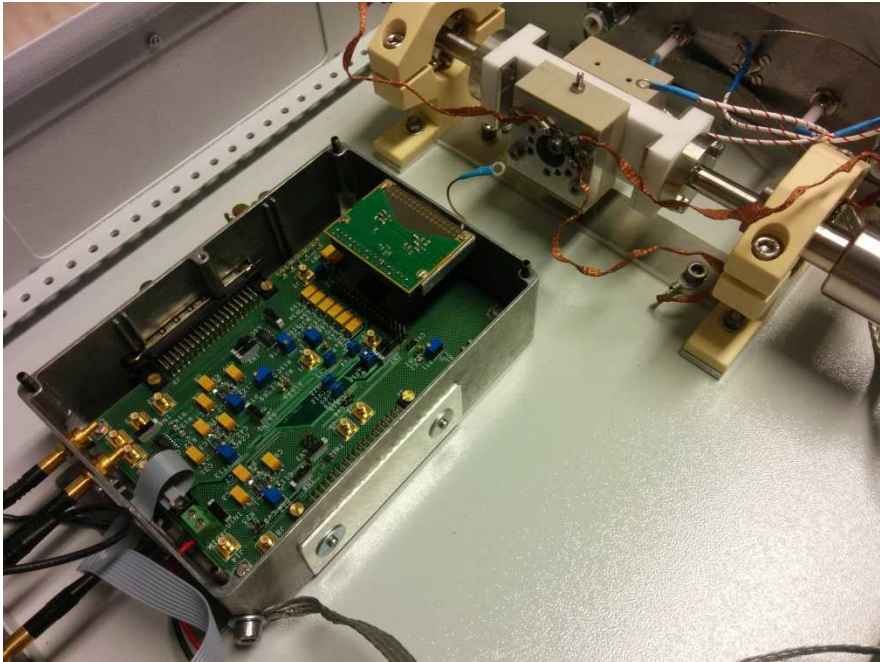


*Frisch grid*

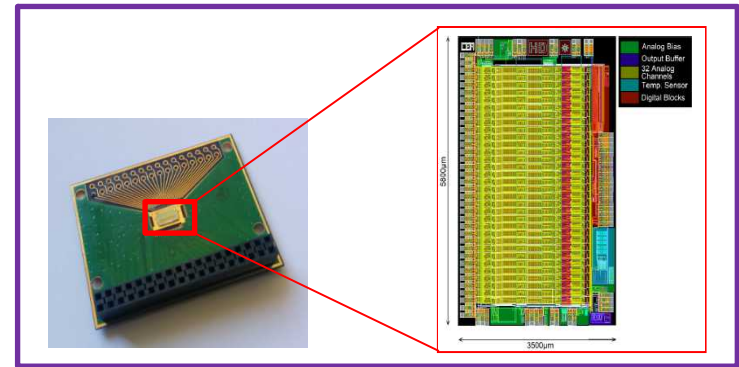


*Charge collection surface*

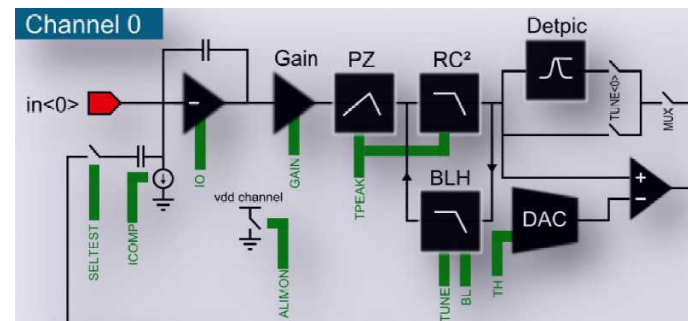
- Charge pre-amplifier □ Low-noise **iDeF-X** electronic developed at SEDI (O. Gevin et al.)
  - Equivalent Noise charge (ENC) = **33 e<sup>-</sup> + 5,5 e<sup>-</sup>/pF**
  - Gain max = **200 mV/fC**
  - 32 independent channels (ASIC)



*Test environment*



*iDef-X chip*

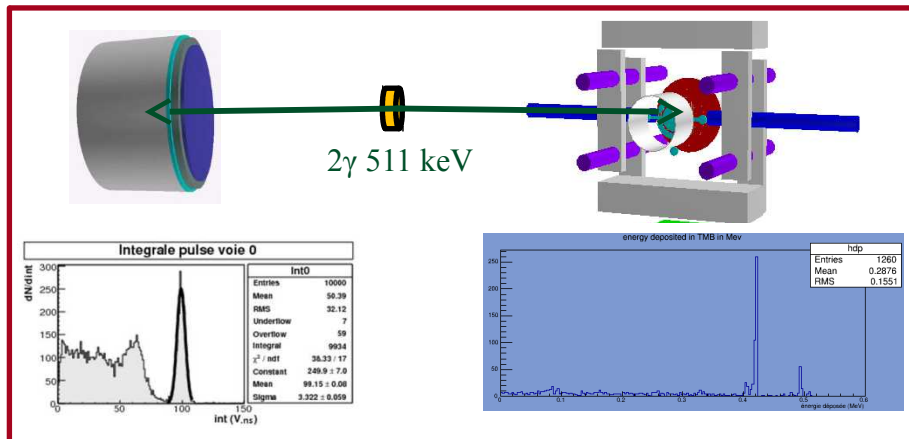
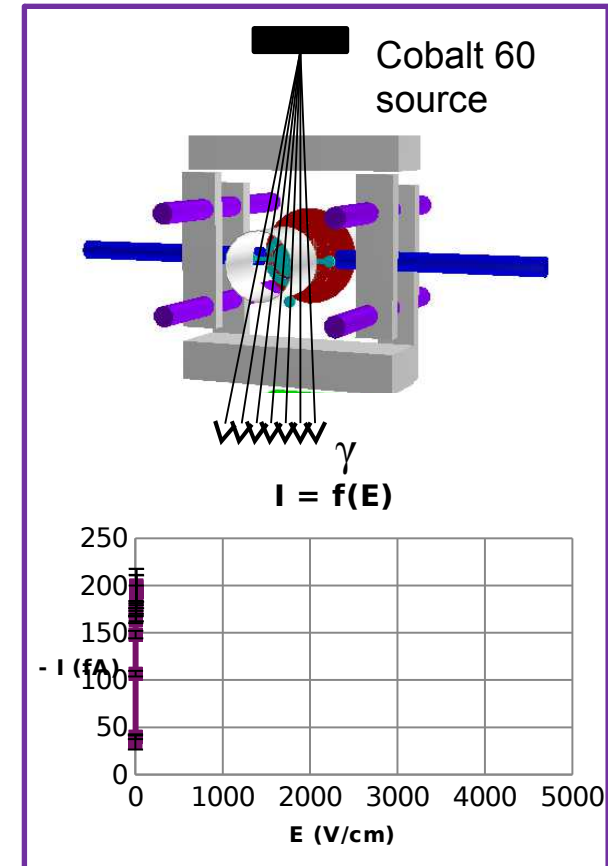
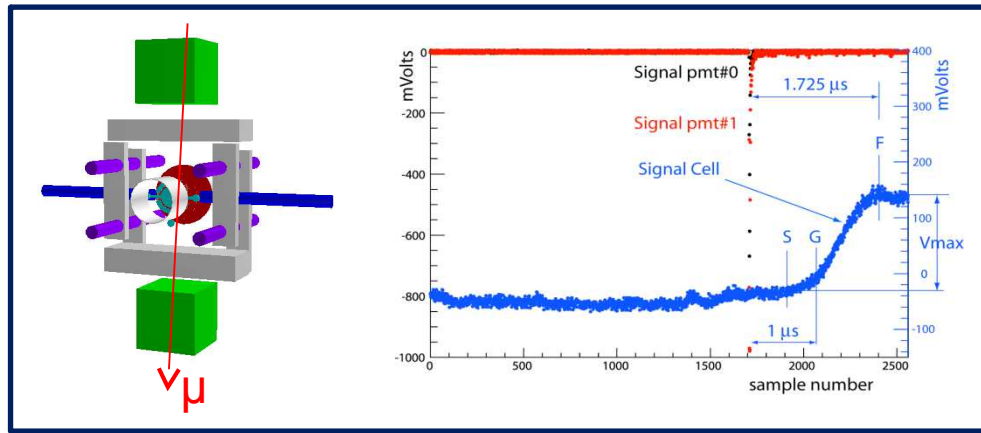


*Schematic of an iDeF-X channel*

# Measurements: 3 methods



- Detection in coincidence of a muon on two scintillators : **Electron mobility**
- produced by a  $^{60}\text{Co}$  gamma rays source : **Charge**
- **Detection yield (Eff)** of two 511 keV  $\gamma$  from a  $\beta^+$   $^{22}\text{Na}$  source : **Ultrapurification**



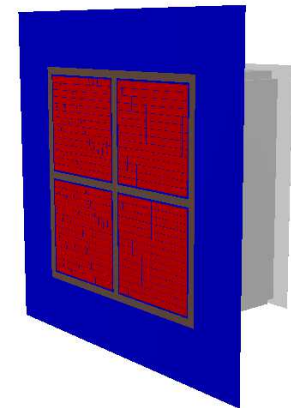
- Now Operational
  - Optical detector
  - Ionization electronic readout
  - Single pixel cell modelisation
  - First ionization signals after purification on 3A zeolites in powder form
- On going
  - TMBi ultrapurification
  - Single pixel cell performance study
  - Mechanical conception of final CaLIPSO detector with « bureau d'étude »
  - Physical modelisation of final detector

Thank you for your attention

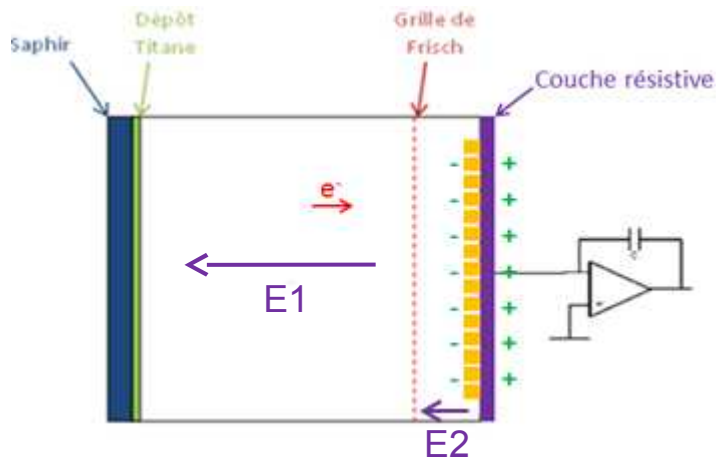


## Signal readout by capacitive coupling

- No feedthrough □
- Alumine 300  $\mu\text{m}$  + resistive layer => **readout by capacitive coupling**
- Thin film deposits on alumine performed by the CSNSM in Orsay (L. Dumoulin et L. Berge)



*Pixellised detector*



*Capacitive readout principle*

